



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideki KOMATSUDA

Group Art Unit: 2851

Application No.: 09/697,639

Examiner: R. Fuller

Filed: October 27, 2000

Docket No.: 105193.01

For: EXPOSURE APPARATUS AND METHOD OF FABRICATING A MICRO DEVICE  
USING THE EXPOSURE APPARATUS

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 6, 2003 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** are reflected in the listing of claims;

**Remarks.**

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